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Electronically Filed February 26, 2009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:	SENZAKI, Yoshihide	Confirmation No.:	3254
Serial No.:	10/524,980	Art Unit:	2823
Filed:	March 22, 2006	Examiner:	LEE, Hsien Ming
For:	<i>Low Temperature Deposition of Silicon Oxides and Oxynitrides</i>	Attorney Docket No:	067538-5172-US

**ASSERTION OF SMALL ENTITY STATUS UNDER 37 C.F.R. § 1.27(c)
AND REQUEST FOR REFUND UNDER 37 C.F.R. § 1.28(a)**

Mail Stop 16
Director of the U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

The Assignee of above application hereby asserts small entity status in accordance with 37 C.F.R. § 1.27(c). Applicants are, therefore, entitled to pay reduced fees in connection with this application. A Verified Statement (Declaration) Claiming Small Entity Status is enclosed herewith.

Under 37 C.F.R. § 1.28(a), Applicants may file a request for a refund of any excess fees paid within three months of the payment of the full fee.¹ Applicants hereby request a refund of the excess fees paid in connection with the above application as follows:

On December 12, 2008, Applicants filed a (1) Request for Continued Examination and (2) a Petition for Extension of Time of three months and paid large entity fees totaling of \$1920.00 in connection with this filing. Applicants hereby request a refund of \$960.00 (the excess amount paid).

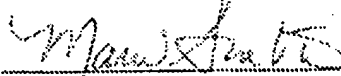
¹ 37 C.F.R. § 1.28(a) ("A refund pursuant to § 1.26, based on establishment of small entity status, of a portion of fees timely paid in full prior to establishing status as a small entity may only be obtained if an assertion under § 1.27(c) and a request for a refund of the excess amount are filed within three months of the date of the timely payment of the full fee.")

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Please credit the refund to Morgan, Lewis & Bockius LLP Deposit Account No. 50-0310
(order no. 067538-5172-US).

Date: February 26, 2009

Respectfully submitted,



37,244

Maria S. Swiatek

(Reg. No.)

Customer No.: 24341

MORGAN, LEWIS & BOCKIUS LLP

2 Palo Alto Square

3000 El Camino Real, Suite 700

Palo Alto, California 94306

Ph. (650) 843-4000

Fax (650) 843-4001

Electronic Patent Application Fee Transmittal

Application Number:

10524980

Filing Date:

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Adjustment date: 03/09/2009 HDESTA1
12/15/2008 INTEFSW 00003918 500310 10524980
01 FC:1253 1110.00 CR
02 FC:1801 810.00 CR

Title of Invention:

Low temperature deposition of silicon oxides and oxynitrides

03/09/2009 HDESTA1 00000004 500310 10524980

01 FC:2253 555.00 DA
02 FC:2801 405.00 DA

First Named Inventor/Applicant Name:

Yoshihide Senzaki

Filer:

Maria S. Swiatek/Vladimir Skliba

Attorney Docket Number:

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Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1110	1110

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1920